

UNCLASSIFIED

AD

402 353

*Reproduced
by the*

DEFENSE DOCUMENTATION CENTER

FOR

SCIENTIFIC AND TECHNICAL INFORMATION

CAMERON STATION, ALEXANDRIA, VIRGINIA



UNCLASSIFIED

PRODUCTION ENGINEERING MEASURES
Crystal Unit CR-(XM-46)/U

SECOND QUARTERLY REPORT
November 1962 to February 1963

Production Engineering Measure (PEM)
in accordance with Step I of Signal Corps
Industrial Preparedness Procurement
Requirement. (SCIPPR) No. 15, dated 1,
October 1958 for Overtone Filter Crystal
Units, 30 - 60 MC/s, CR-(XM-46)/U Per
Specification SGS-135 dated 20 February
1962.

Contract #DA-36-039-SC-86737

Order #19059-PF-62-81-81

E.B. LEWIS CO., INCORPORATED
East Hartford, Conn.

Prepared by

Approved by

Approved by

Robert P. McComb
Robert P. McComb

Ernest B. Lewis
Ernest B. Lewis

Charles G. Robb
Charles G. Robb

TABLE OF CONTENTS

	Page
Title Page	i
Table of Contents	ii
Illustrations	iii
Purpose	1
Abstract	2
Narrative	3
Conclusions	9
Program Next Interval	10
Conferences	11
Man Hours	12

ILLUSTRATIONS

Figure

- 1 Design of Tungsten Base Plating Filament
- 2 Electrode Configuration using Dovetail Tab Design
- 3 Electrode Configuration using Improved Design
- 4 Mode Configuration SC-1307 Crystal Mounted on θ θ'
- 5 Mode Configuration SC-1307 Crystal Mounted on X-X'
- 6 Design of SC-1307 Crystal Mounted on θ θ'
- 7 Design of SC-1307 Crystal Mounted on X-X'
- 8 Specimen Work Order of E. B. Lewis Co., Incorporated

SECOND QUARTERLY REPORT

Contract #DA-36-039-SC-86737
Order #19059-PF-62-81-81

CR-(XM-46)/U

Purpose:

The purpose of this study is to design and carry out the production engineering necessary for the manufacture of quartz crystals for filter applications operating on the third overtone in the frequency range of 30 to 60 MC/s in accordance with Signal Corps Specification SCS-135 dated 20 February 1962.

It is also the purpose of this program to carry out Step I of the Production Engineering Measures as specified in Signal Corps Industrial Preparedness Procurement Requirements #15 dated 1 October 1958.

[illegible]

1
2
3
4
5
6
7
8
9
10
11
12

1

2

3

4

5

6

7

8

9

10

11

12

13

14

15

16

17

18

19

20

21

22

23

24

25

26

27

28

29

30

31

32

33

34

35

36

37

38

39

40

41

42

43

44

45

46

47

48

49

50

51

52

53

54

55

56

57

58

59

60

61

62

63

64

65

66

67

68

69

70

71

72

73

74

75

76

77

78

79

80

81

82

83

84

85

86

87

88

89

90

91

92

93

94

95

96

97

98

99

100

101

102

103

104

105

106

107

108

109

110

111

112

113

114

115

116

117

118

119

120

121

122

123

124

125

126

127

128

129

130

131

132

133

134

135

136

137

138

139

140

141

142

143

144

145

146

147

148

149

150

151

152

153

154

155

156

157

158

159

160

161

162

163

164

165

166

167

168

169

170

171

172

173

174

175

176

177

178

179

180

181

182

183

184

185

186

187

188

189

190

191

192

193

194

195

196

197

198

199

200

201

202

203

204

205

206

207

208

209

210

211

212

213

214

215

216

217

218

219

220

221

222

223

224

225

226

227

228

229

230

231

232

233

234

235

236

237

238

239

240

241

242

243

244

245

246

247

248

249

250

251

252

253

254

255

256

257

258

259

260

261

262

263

264

265

266

267

268

269

270

271

272

273

274

275

276

277

278

279

280

281

282

283

284

285

286

287

288

289

290

291

292

293

294

295

296

297

298

299

300

301

302

303

304

305

306

307

308

309

310

311

312

313

314

315

316

317

318

319

320

321

322

323

324

325

326

327

328

329

330

331

332

333

334

335

336

337

338

339

340

341

342

343

344

345

346

347

348

349

350

351

352

353

354

355

356

357

358

359

360

361

362

363

364

365

366

367

368

369

370

371

372

373

374

375

376

377

378

379

380

381

382

383

384

385

386

387

388

389

390

391

392

393

394

395

396

397

398

399

400

401

402

403

404

405

406

407

408

409

410

411

412

413

414

415

416

417

418

419

420

421

422

423

424

425

426

427

428

429

430

431

432

433

434

435

436

437

438

439

440

441

442

443

444

445

446

447

448

449

450

451

452

453

454

455

456

457

458

459

460

461

462

463

464

465

466

467

468

469

470

471

472

473

474

475

476

477

478

479

480

481

482

483

484

485

486

487

488

489

490

491

492

493

494

495

496

497

498

499

500

501

502

503

504

505

506

507

508

509

510

511

512

513

514

515

516

517

518

519

520

521

522

523

524

525

52

[illegible]

NARRATIVE

As was reported in the First Quarterly Report, the two major problems that arose were unsuitable surface conditions and unacceptable electrode plating.

A rigorous investigation of the lapping and polishing procedures was undertaken as the first objective.

The majority of all crystals fabricated by E. B. Lewis Co., Inc. prior to any work concerned with this contract did not involve extensive polishing technique.

All lapping operations were performed on P.R. Hoffman Model PR-1 Planetary Lapps. The polishing was done on two VanConey Lapps. The extent of the polish was more in the way of a finish lapping operation using American Optical #309 polishing compound, with a particle size of one to three microns. It was noticed that in the attempt to achieve a finer finish using the American Optical #309, the resistance of the crystal units was improved to a point. However, as the degree of polish was increased, the resistance of the crystals suddenly increased to a point where they would be unacceptable.

It was soon realized that the crystals required on this contract would require a much finer finish, further in the higher frequency range it would be necessary to control the losses due to breakage when lapping the very thin plates.

Equally important would be the control of flatness and frequency spread. For these reasons it became necessary to use the Phelpor Model 12PF Planetary Lapp or the P. R. Hoffman PR-4. For polishing the VanConey Lapps are satisfactory with the exception of a speed increase from 750 RPM to 1200 RPM.

Finish Lapping Operation:

For crystals operating on the third overtone at 30 MC/s, the fundamental frequency is 10 MC/s. Twenty-four .312 diameter blanks in six carriers comprise the load. The blanks are 8425. ± 25 KC/s out of intermediate lapping. Intermediate lapping is done in a PR-1 using Carborundum Company KC Abrasive with a grain size of 11 microns.

The crystals are then lapped using American Optical M305 Abrasive and a radio receiver to monitor frequency. At 10 MC/s the frequency spread is approximately 10 KC/s. Present procedures require that the lapping plates be corrected when the frequency spread approaches 20 KC/s.

The Pre-Polish frequency is determined in such a way that for two minutes of polish they will be well within the Pre-Plate frequency tolerance.

Polishing Operation:

The crystals are run in the VanConey Lapping Machine for two minutes. The polishing compound used is composed of white rouge, distilled water, tri-sodium phosphate and a wetting agent.

The frequency after polishing is 10,035 KC/s ± 10 KC/s. Prior to base plating the crystals are frequency calibrated and sorted into groups where the maximum spread is ± 2.5 KC/s.

The problem of a suitable electrode plating was next investigated.

An evaluation was made on the basis of the first crystals fabricated. It would appear at this time that an all aluminum electrode will be necessary.

The first difficulty encountered was an inconsistency in the amount of plate back obtained using both a tungsten filament in the Constantin Model 3 and our own National Research Model CG Base Plater using molybdenum boats.

It was found that an amalgamation occurred between the aluminum and tungsten which caused less aluminum to be evaporated on the crystals with each successive plating operation, and finally a complete deterioration of the filament.

This has been overcome by the construction of a specially formed filament which is essentially helical in shape and made up of five turns of tungsten wire consisting of three strands approximately .030 inches in diameter. This filament configuration has proved to be the most durable to date, and is shown in Figure 1.

Special cylindrical chambers were made up for use with the Model 3 Constantin Plater to facilitate the mounting of the masks. A glass plate is used as a cover to allow observation of the firing. We are planning to introduce a resistance measuring device so that uniform conductivity with each successive firing can be obtained.

A further problem which has developed with the use of aluminum is the loss of conductivity between the spring contact and the plated electrode both before and after beading, but much more severe after beading. We believe this is due to an oxide formed on the surface of the aluminum electrode. At present the crystals are immediately mounted into the holders after base plating and cement beads applied to the springs. The cement used is DuPont #5504 and is baked at 135° C for a period of 1-1/2 to 2 hours. This procedure solved the problem of conductivity loss, however it was noted that on further investigation it was found that loss of conductivity was not as serious as first anticipated if the crystals were processed immediately after base plating and stored at 132° C.

Final frequency adjustment is made by etching the electrode with a .5% solution of NaOH. The etching time required for final frequency adjustment is determined primarily by the strength of the etching solution and the amount of base plate previously applied. At present, satisfactory results are obtained using the .5% NaOH solution on crystals that are 30 to 10 KC/s below the "Finished" or "Final" frequency.

The next procedure was to determine the optimum electrode diameter which would permit us to meet the parameters specified in the SOS-135 Specification. The procedure is based on previous work done by Dr. Rudolph Bechmann of the United States Army Signal Research and Development Laboratory, Fort Monmouth, New Jersey.

A new electrode diameter was decided upon and a new mask ordered, however, it was not available in time for evaluation in this report. But one of our production masks with the proper diameter electrode and a slightly different tab design was used successfully. The design of this electrode as well as the new one are shown in Figures 2 and 3.

Crystals fabricated with the new electrode diameter were designated SC-1307. X-Y Plots of two of these crystals mounted on Z,Z' and X,X' respectively are shown in Figures 4 and 5.

Table I presents a comparison of the parameters for the SC-1430 and SC-1307 units with the maximum values obtained from the SCS-135 Specification.

The assembly of the SC-1307 is shown in Figures 6 and 7 for crystal units mounted on Z,Z' and X,X' respectively.

TABLE I

SC-1430	SC-1307	SCS-135
$f_o = 30 \text{ MC/s}$	$f_o = 30 \text{ MC/s}$	$f_o = 30 \text{ MC/s}$
$C_o = .989 \text{ pf}$	$C_o = 1.22 \text{ pf}$	$C_o = 1.5 \text{ pf}$
$R = 250 \text{ ohms}$	$R = 80.7 \text{ ohms}$	$R = 100 \text{ ohms}$
$df = 95 \text{ cps}$	$df = 211 \text{ cps}$	$df = 200 \text{ cps}$
$C_1 = 1.33 \times 10^{-4} \text{ pf}$	$C_1 = 3.89 \times 10^{-4} \text{ pf}$	$C_1 = 3 \times 10^{-4} \text{ pf}$
$x = 7439$	$r = 3154$	$r = 5000$
$Q = 158 \times 10^3$	$Q = 169 \times 10^3$	$Q = 179 \times 10^3$
$L = 209 \text{ mhy}$	$L = 72.3 \text{ mhy}$	$L = 93.4 \text{ mhy}$

Conclusions:

It is evident that the requirements of the SOS-135 Specification with regard to unwanted modes and electrical parameters can be met for the 30 MC/s frequency range.

The techniques that we are now using for final lapping and polishing will be adequate for production in quantity of the CR-(XM-46)/U crystal in the 30 MC/s frequency range.

It will be necessary, however, to work out a more efficient method of aluminum plating so that the frequency spread after base plating is held to a much closer tolerance to facilitate a more rapid rate of production in final frequency finishing.

Program for the Next Interval:

In the immediate future we will process a sufficiently large lot of crystals at the 30 MC/s frequency; from this lot samples for submission to USASRDL will be selected. The remainder of the units will be evaluated and a statistical analysis made to determine where any problems might arise in production.

Initial work on the design of the 45 MC/s units will be started during this time.

Conferences:

During the interval covered by this report, the following conferences were held.

26, 27 and 28 November 1962, Mr. Albert E. Schlick, Property Manager, U. S. Army Electronics Materiel Agency, visited our plant for the purpose of assisting us in the completion of the DD1342 forms and outlining the contractors responsibility concerning the administration and accountability for government owned property.

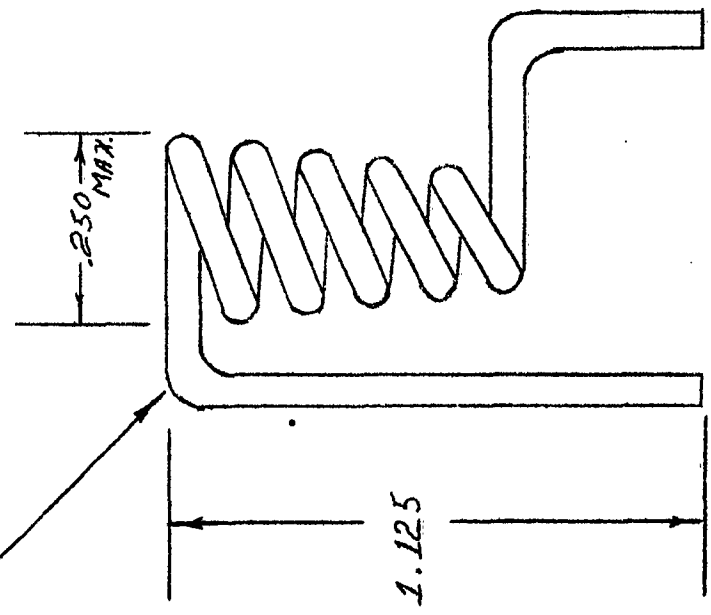
3 January 1963, Mr. H.J. Barrett, Industrial Equipment Specialist, U. S. Army Electronics Materiel Agency, Industrial Equipment Division, visited our plant for the purpose of accepting for the government the final three items under Schedule "A" Facilities that were acquired for the account of the government.

23 and 24 January 1963, Mr. Santo Tutino, Auditor, Bridgeport Area Office, U. S. Army Audit Agency visited our plant for the purpose of audit.

MAN HOURS

Ernest B. Lewis	20.0
Robert P. McComb	224.5
Crystal Fabrication	<u>39.6</u>
TOTAL MAN HOURS	284.1

TUNGSTEN WIRE
STRANDED 3/030



FILAMENT CONSTRUCTION
FOR
BASE PLATING

FIGURE 1

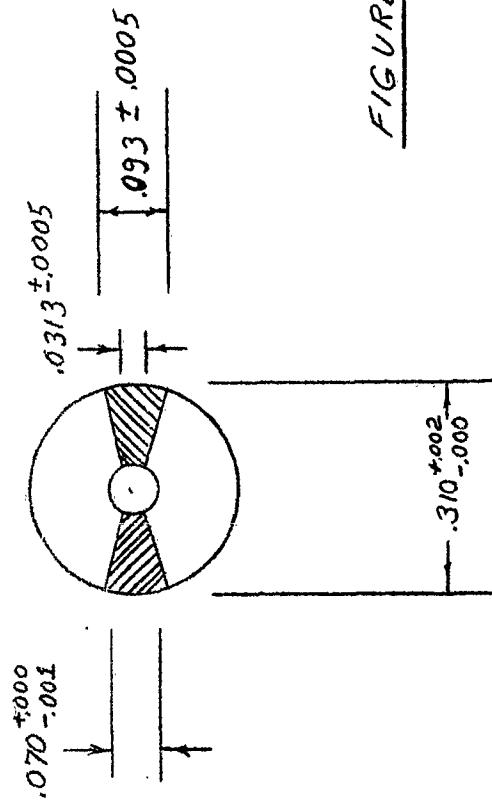


FIGURE 2

PLATING CONFIGURATION
USING DOVETAIL
LEAD-OFF

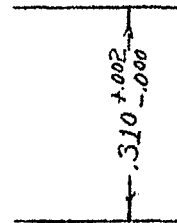
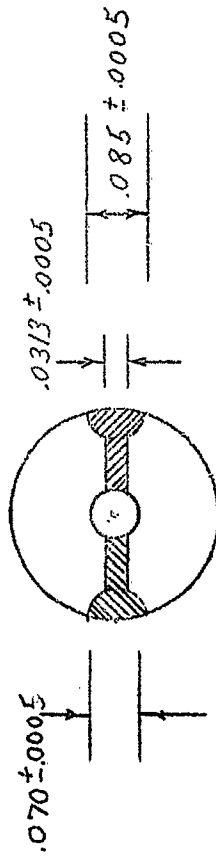
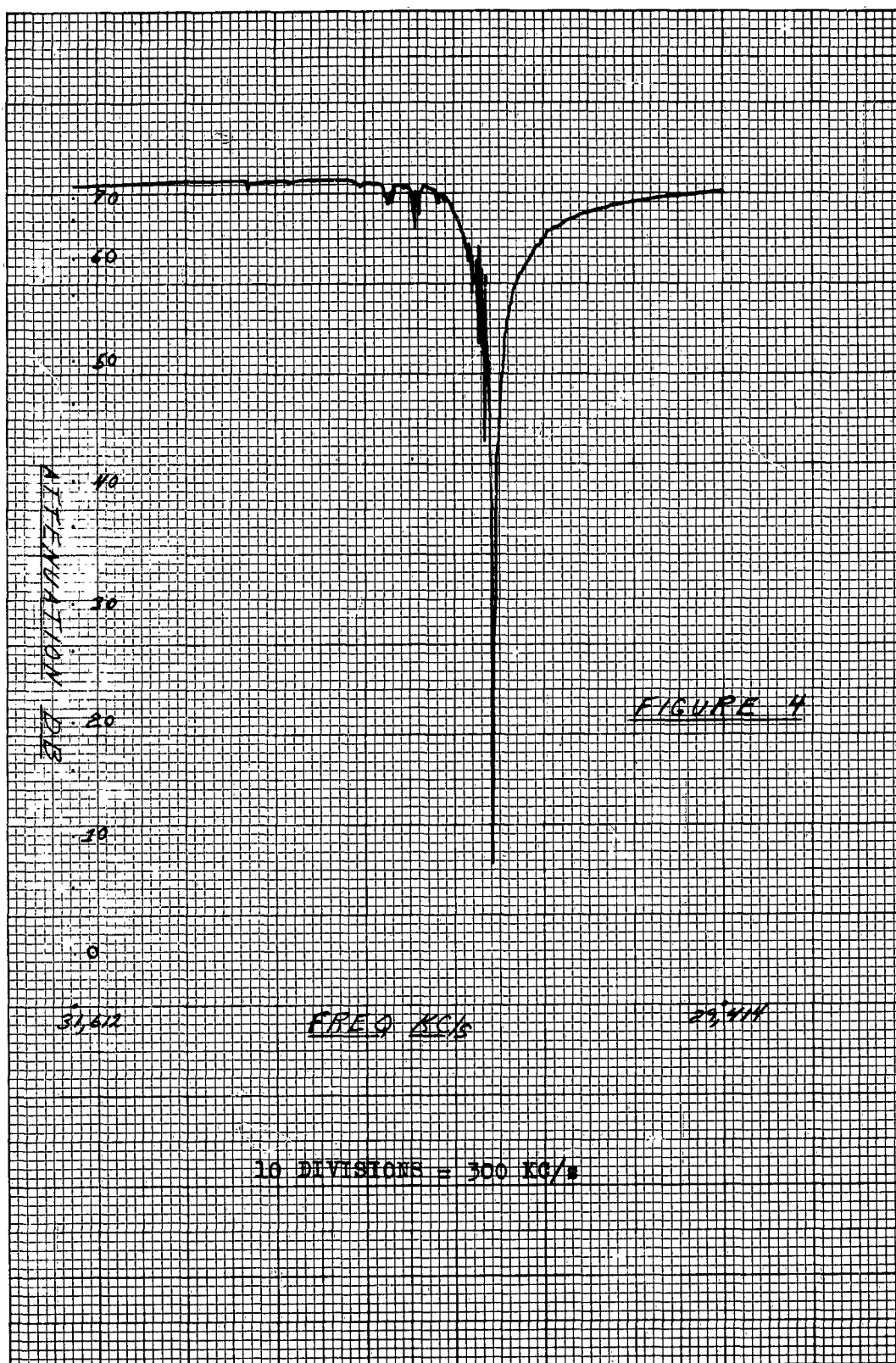
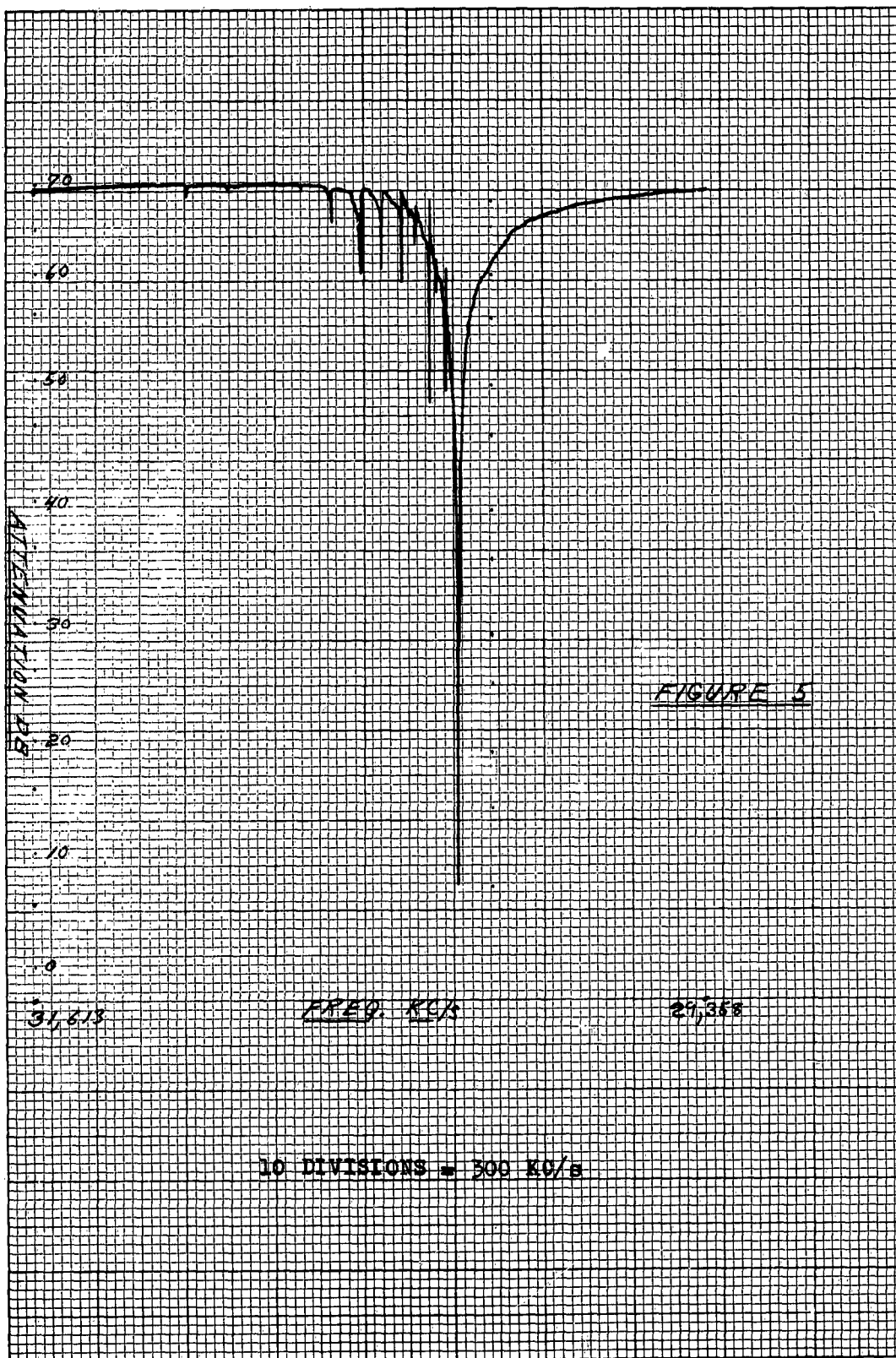
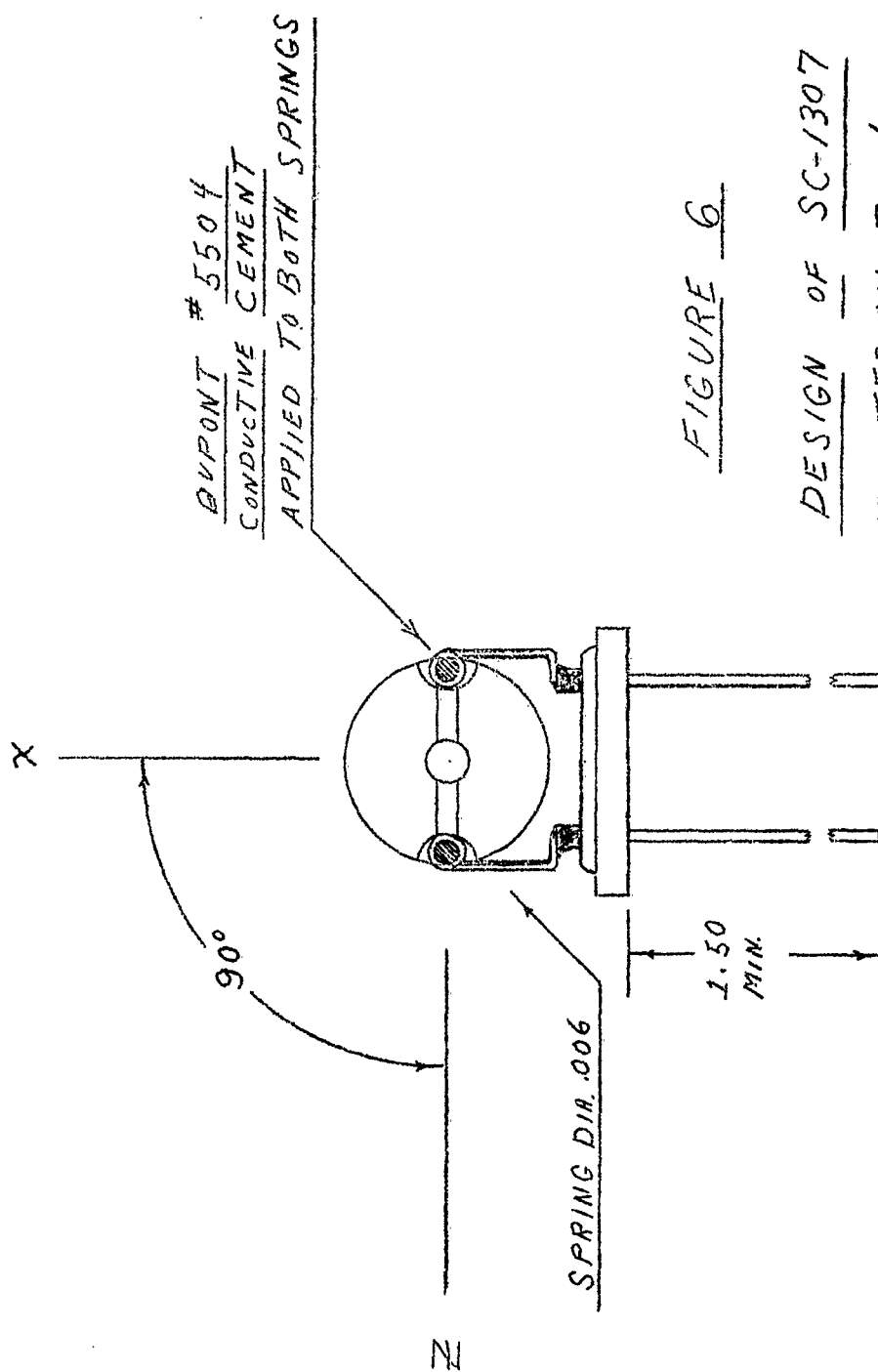


FIGURE 3

PLATING CONFIGURATION
USED ON SC-1307
CRYSTAL UNITS







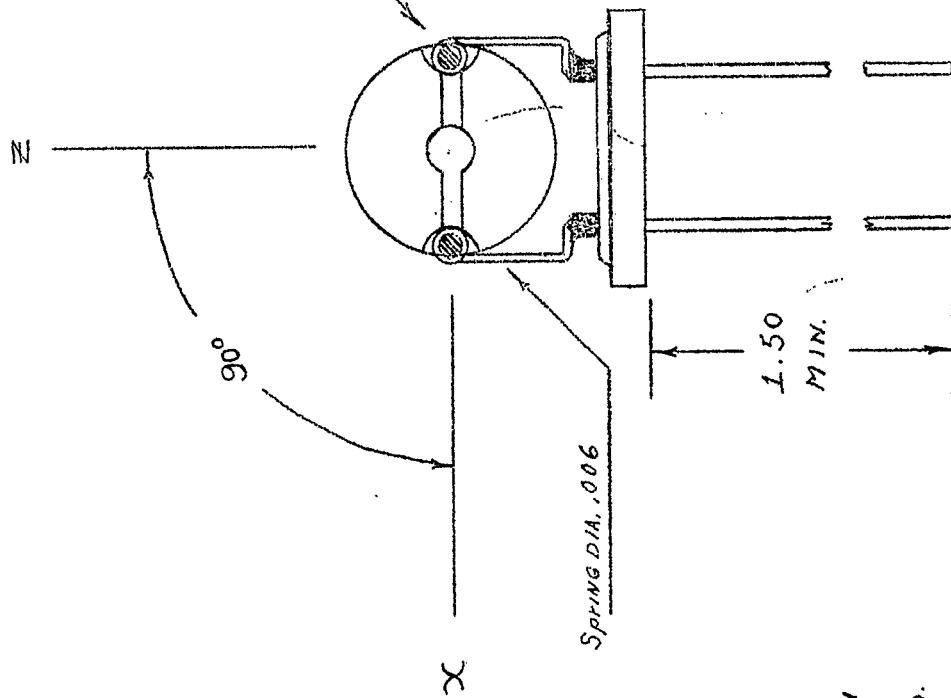


FIGURE 7

DESIGN OF SC-1307
MOUNTED ON X-X'

Holder: HC-18/u

MEL SMITH Co.

PART No. B11180-3

E. B. LEWIS CO., INC. EAST HARTFORD, CONN.

FOR

SHIP TO

USAEMA
PHILADELPHIA, PENNA

PROMISED DELIVERY DATE

Jan 15, 1963

DESCRIPTION:

ITEMS 1-1-1
ENGINEERING SAMPLES
15 Ea. @ 30.000 MC/S
Natural Quartz

CONT# DA-36-039-SC-86737
ORDER# 19059-PP-62-81-81

S. O. EL 6843-B

P.O. _____

DATE Dec 27, 1962

How Shipped _____

Process 50 pieces
AC-18/u

SC-1

Cutting $35^{\circ} 27' \pm 2'$

SCHEDULED
FOR:

Squaring .310 $\pm .002$ dia $\frac{1}{16}$ " flat Parallel ZZ'

Lapping Flat and Parallel to one light band
2 MIN. Polish

Preplate freq. + 60 KC/s
Prepolish freq = 2F 60 KC/s / 2 MIN
Out of Intermediate Lapp 8425 ± 25 KC/s

Plating
.064 dia. TABS 071 ZZ'
.064 dia TABS 071 XX'
.075 dia TABS 071 ZZ'

Finishing .075 dia TABS 071 XX'

Oscillator TS683 1 MW drive 100 ohms MAX
Correlation

Load Cap. 20 pf $\pm 2\%$

Testing Mil-C-3098/c

SCS-135

Shipping

OFFICE COPY

APPENDIX I

Formulae for Crystal Parameters

$$(1) \quad C_1 = \frac{C_0}{r}$$

$$(2) \quad r = \frac{C_0 (F_s)}{2 df (C_0 + C_L)}$$

$$(3) \quad Q = \frac{1}{w C_1 R}$$

$$(4) \quad L = \frac{XL}{w}$$

Where:

C_1 = Motional Capacitance

C_0 = Static Capacitance to one decimal place

C_L = Load Capacitance in pf (20.0)

r = Ratio of Static Capacitance to Motional Capacitance

df = Difference in frequency (in CPS) between Series Resonance and Anti Resonance at 20.0 pf when measured in Crystal Impedance Meter TS-683/TSM

F_s = Measured Series Resonant frequency of the crystal unit in CPS

R = Equivalent resistance of the crystal unit at Series Resonance.

$w = 2 \pi F_s$